



I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on the date shown below.

Dated: 10/21/03

Signature:
(Christa Carter)

Docket No.: 333772000101
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Akihiko ITO, et al

Application No.: 09/964,211

Group Art Unit: 2858

Filed: September 25, 2001

Examiner: J. Kerveros

For: SEMICONDUCTOR DEVICE TESTING
APPARATUS AND A TEST TRAY FOR USE
IN THE TESTING APPARATUS

RESPONSE

Commissioner for Patent
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

This is in response to the non-final Office Action dated May 23, 2003 (Paper No. 5) for which a response was due on August 23, 2003. Filed herewith is a Petition and fee for a two-month(s) extension of time, thereby extending the deadline for response to October 23, 2003. Accordingly, this response is timely filed. Reconsideration and allowance of the pending claims in light of the remarks presented herein are respectfully requested.

RECEIVED
OCT 31 2003
TECHNOLOGY CENTER 2800

AMENDMENTS

In the specification

On page 1, please amend the paragraph beginning on line 5 as follows:

This application is a continuation of U.S. Application Serial No. 09/254,084, entitled "Semiconductor Device Testing Apparatus and a Test Tray for Use in the Testing Apparatus", and filed on February 26, 1999, now U.S. Patent No. 6,459,259.